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PATENT APPLICATION

#4/A  
4/14/03  
M. Pridgen

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomoko OHTSUKI

Application No.: 10/070,682

Filed: September 4, 2002

Docket No.: 112161

For: EXPOSURE APPARATUS WITH LASER DEVICE

PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office  
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Page 1, before line 1, insert a new paragraph as follows:

-- This application is the national phase under 35 U.S.C. 371 of prior PCT

A1  
International Application No. PCT/JP00/06130 which has an International filing date of  
September 8, 2000 which designated the United States of America, the entire contents of  
which are hereby incorporated by reference. --

Page 7, lines 21-27 and Page 8, lines 1-9, delete current paragraph and insert therefor:

A first exposure apparatus of the present invention illuminates a pattern of a first  
object with ultraviolet light from a laser device and exposes a second object with the  
ultraviolet light which has passed through the first object, wherein the laser device includes a  
laser light generation section which generates single wavelength laser light in a wavelength  
range of from an infrared region to a visible region; an optical amplification section including